

RECEIVED
CENTRAL FAX CENTER

OCT 18 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Wu et al.) Group Art Unit: 2891
 Serial No.: 10/672,778) Examiner: Smith, Bradley
 Filed: September 26, 2003) Confirmation No.: 9717
 For: Atomic Layer Deposition (ALD) Method with) TKHR Docket: 252016-3000
 Enhanced Deposition Rate) Top-Team: 0503-8501DUS
)

CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 CFR §1.8

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being transmitted on the date indicated below via facsimile to the United States Patent and Trademark Office, Technology Group 2100, facsimile number (571) 273-8300. Total number of pages in this transmission 7

October 18, 2005

Date



Hui Chin Barnhill

RESPONSE TO RESTRICTION/ELECTION REQUIREMENTS

Mail Stop Amendment
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, Virginia 22313-1450

Sir:

The Office Action mailed September 22, 2005 has been carefully considered. In further response thereto, please enter the following amendments and consider the following remarks.

BEST AVAILABLE COPY